FIG. 1

<u>10</u>

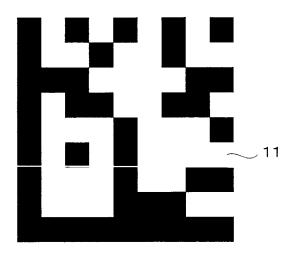


FIG. 2

<u>20</u>

21



FIG. 3

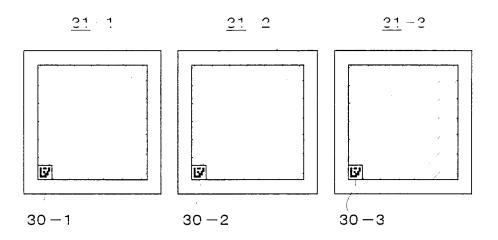
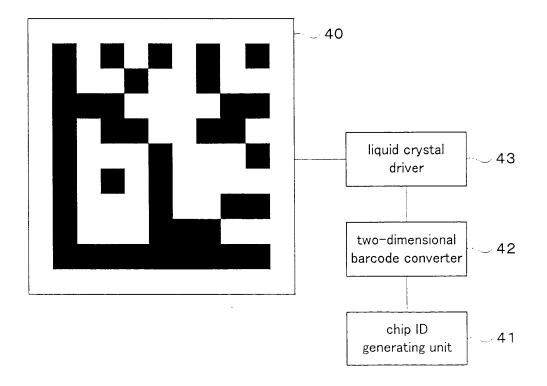


FIG. 4



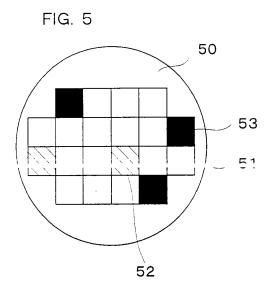
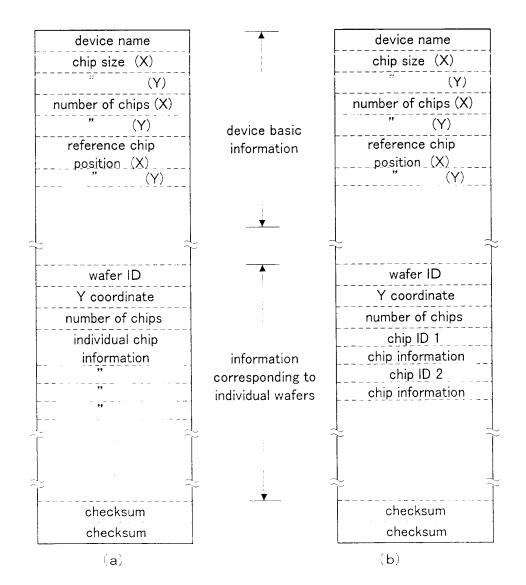


FIG. 6

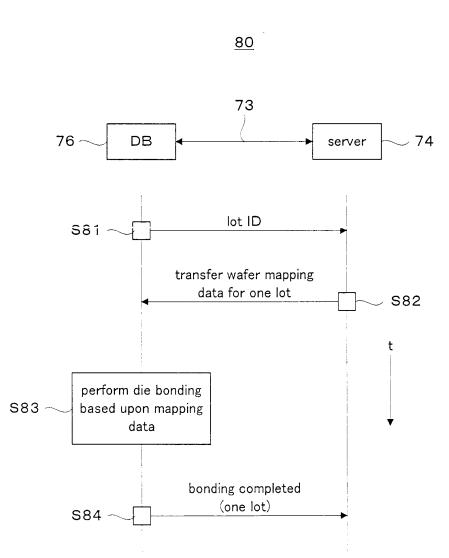


database 75 printer 78 74 data server WB 9, DB , 71 ш to probing LAN

72

chi) sort 3r

FIG. 8



3.7

FIG. 9

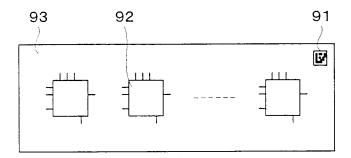


FIG. 11

frame ID
number of chips
chip ID 1
chip ID 2
;
chip ID N

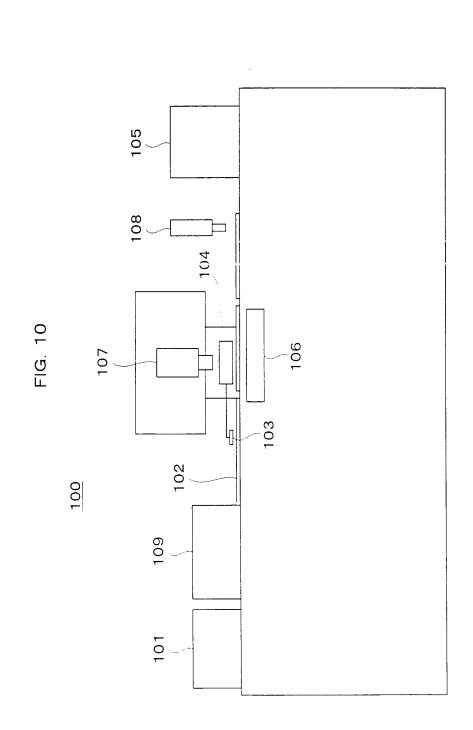
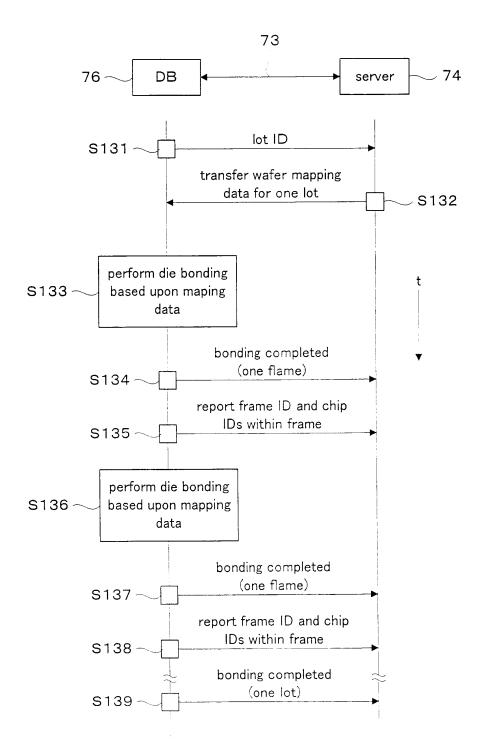


FIG. 12

* * * * * * * * *	* * * *	*	collected data	* * *	- !	* * *	* * *	
			processig device	* *		* *	* *	
product code	wafer process flow No.	wafer process flow No. probing category code	processing date	* * *		* * * *	* * *	
			manufacturing conditions	bonding conditions * * *		wiring pattern * * *	printing pattern * * *	
	* * * *			* * * *		* * *	* * *	
	chip ID		process	die bonding		wire bonding	printing	

FIG. 13

130



145 143

FIG. 15

<u>150</u>

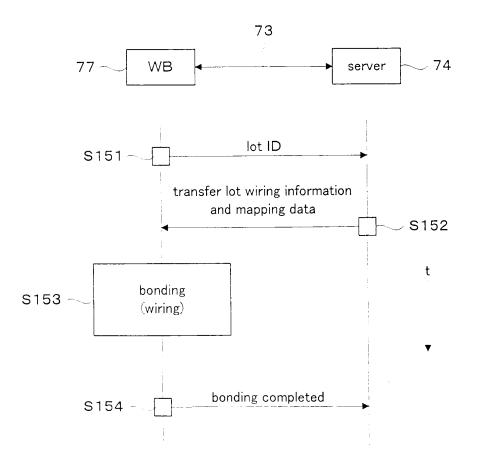


FIG. 16

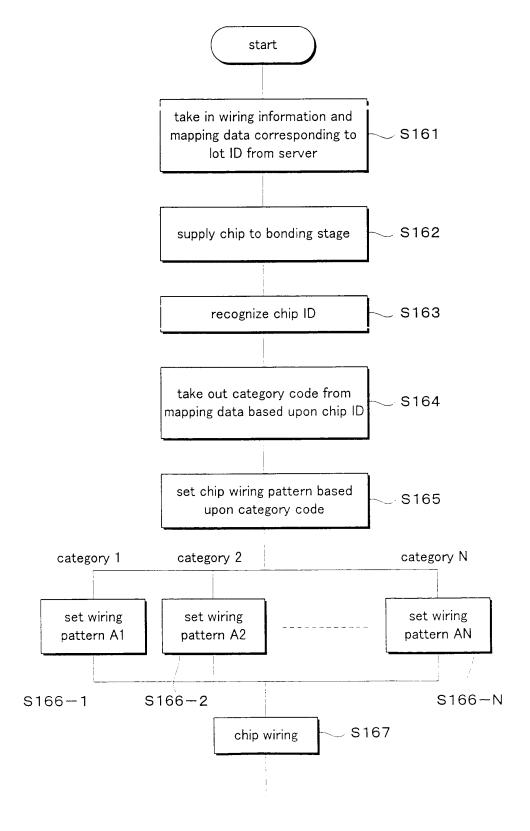
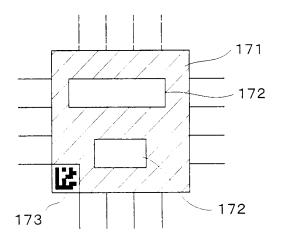


FIG. 17



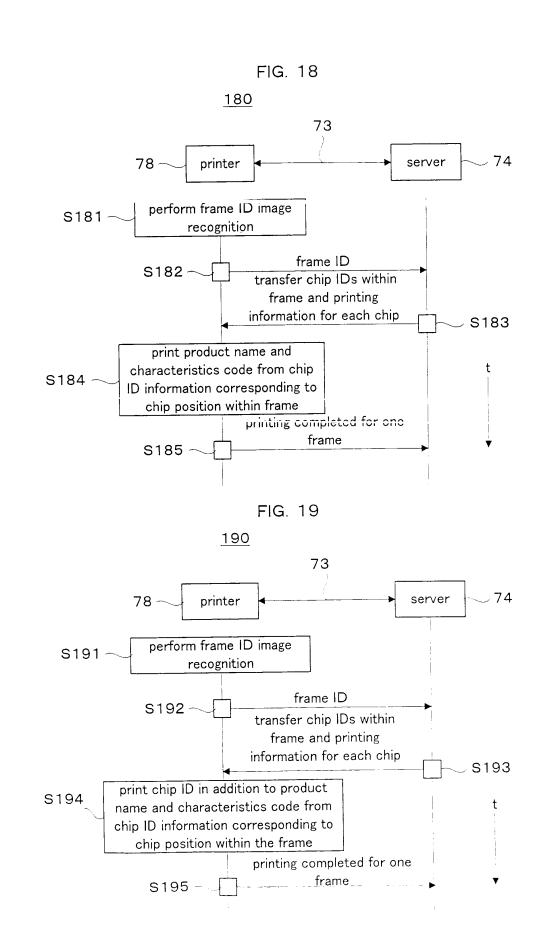
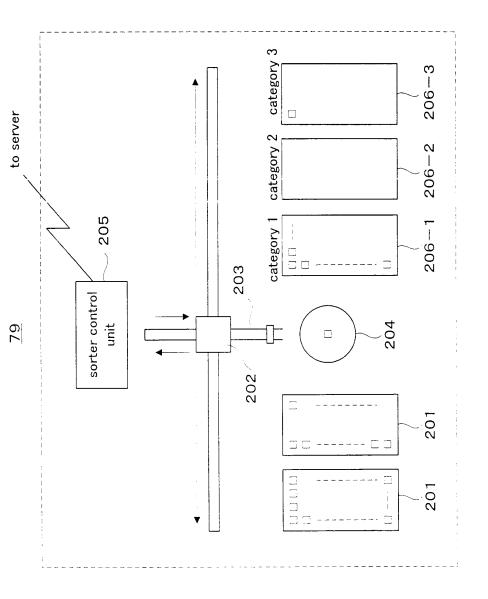


FIG. 20



Chip ID information table

- wafer process
 processing history information
- assembly processprocessing history information
 - 3. text data*probing
 - *chip status

FIG. 22

Chip ID information table

- wafer process
 processing history information
- assembly processprocessing history information
 - 3. text data
 - *probing
 - *chip status
 - 4. shipping information

shipping destination packaging status shipping data

5. post-shipment field claim information

claim history